# Nano-SPM200

#### Features

- ▶ Compact size
- ▶ 200 µm two axis motion (XY)
- ► Closed loop control
- True flexure guided motion
- Large sample mounting area

#### **Typical Applications**

- AFM, NSOM and other types of scanning probe microscopy
- XY precision alignment
- ▶ Nanofabrication



### **Product Description**

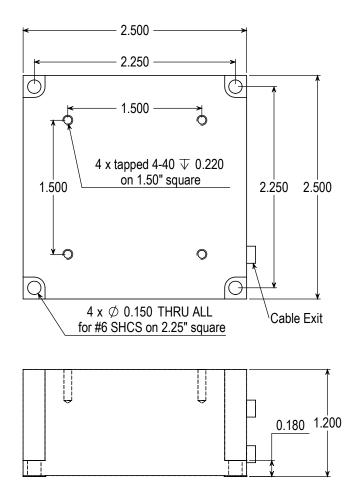
The Nano-SPM200 is a compact two axis (XY) nanopositioning system constructed from aluminum. The compact design of the Nano-SPM200 makes it ideal for integration into scanning probe microscopy systems. Internal position sensors combined with the closed loop Nano-Drive controller to provide sub-nanometer positioning resolution and long term stability. Independent Nano-SPM200 shown with micrometer XY coarse positioning stage.

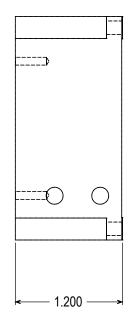
flexure guided motion for each axis provides mechanical isolation and ensures minimum cross-talk between axes. Samples can be mounted in any location on the flat top surface and secured with the four threaded mounting holes. The Nano-SPM200 is the ideal XY scanning stage for use with the MadPLL system.



## **Technical Specifications**

Ranges of motion (XY) 200 $\mu m$
Resolution0.4 nm
Resonant Frequency (X) 300 Hz ±20%
Resonant Frequency (Y) 300 Hz ±20%
Stiffness1.0 N/µm
Recommended max. load (horizontal)*0.5 kg
Recommended max. load (vertical)*0.2 kg
Body Material Aluminum
Controller Nano-Drive®
* Larger load requirements should be discussed with our engineering staff.





Note: All Dimensions in Inches

MC